

FORM PTO-1449	U.S. DEPARTMENT OF COMMERCE PATENT AND TRADEMARK OFFICE	ATTY. DOCKET NO. 100564-00049	SERIAL NO. New Application
LIST OF REFERENCES CITED BY APPLICANT (Use several sheets if necessary)		APPLICANT STÄHLER et al	
		FILING DATE February 28, 2001	GROUP

U.S. PATENT DOCUMENTS

EXAMINER INITIAL		DOCUMENT NO.	DATE	NAME	CLASS	SUB- CLASS	FILING DATE
PP	AA	5,318,679	6/7/94	Nishioka			
PP	AB	5,424,186	6/13/95	Fodor et al			

FOREIGN PATENT DOCUMENTS

		DOCUMENT NO.	DATE	COUNTRY	CLASS	SUB- CLASS	TRANSLATION YES NO	
PP	AC	98 08085	2/26/88	WO				
	AD	99 41007	8/19/99	WO				
	AE	99 42813	8/26/99	WO				
	AF	99 60156	11/25/99	WO				
	AG	99 63385	12/9/99	WO				
✓	AH	98 13683	4/2/98	WO				

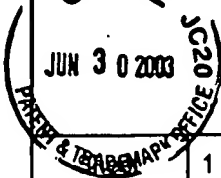
OTHER REFERENCES (Including Author, Title, Date, Pertinent Pages, Etc.)

PP	AI	Davidson, "A microlens direct-write concept for lithography", INSTITUTE OF ELECTRICIA ENGINEERS, vol. 3048, pgs. 346-355.
	AJ	Bertsch et al., "Study of the spatial resolution of a new 3D microfabrication process...." CHEMICAL ABSTRACTS, vol. 127, no. 15, 13 October 1997
	AK	Sangeet et al., "Maskless fabrication of light-directed oligonucleotide microarrays using a digital micromirror array", NATURE BIOTECHNOLOGY, vol. 17, October 1999, pgs. 974-978.
	AL	Retrieved form the Internet: "Digital Optical Chemistry", retrieved on 12/20/99, URL: http://pompos.swmed.edu/exptbio/dec
	AM	Johnson et al., "Micromirror arrays perform photolithography step", EETIMES. COM Online, 20 December 1999.
✓	AN	Bertsch et al., "Study of the spatial resolution of a new 3D microfabrication process....", CHEMICAL ABSTRACTS, vol. 127, no. 15, 13 October 1997

EXAMINER P. Ponnalan	DATE CONSIDERED 1/18/05
<p>*EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.</p>	

INFORMATION DISCLOSURE STATEMENT BY APPLICANT

JUN 30 2003



Complete if Known

Application Number 09/763,607
Filing Date April 19, 2001
First Named Inventor Cord F. STÄHLER et al.
Group Art Unit 1639
Examiner Name Maurie Garcia Baker
Attorney Docket Number 2923-436

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OTHER PRIOR ART - NON PATENT LITERATURE DOCUMENTS

Examiner Initials*	Cite No. ¹	Include name of the author (in CAPITAL LETTERS), title of the article (when appropriate), title of the item (book, magazine, journal, serial, symposium, catalog, etc.), date, page(s), volume-issue number(s), publisher, city and/or country where published	T ²
pp	AO	Search Report from the German Patent and Trademark Office issued August 9, 1999 and English Translation Thereof	✓
pp	AP	Search Report from the German Patent and Trademark Office issued April 17, 2000 and English Translation Thereof	✓

Examiner
Signature

P. Ponnalun

Date
Considered

1/18/05

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¹Unique citation designation number. ²Applicant is to place a check mark here if English language Translation is attached.